



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant:** H. ATWATER et al.

**Title:** WAFER BONDED EPITAXIAL  
TEMPLATES FOR SILICON  
HETEROSTRUCTURES

**Appl. No.:** 10/784,586

**Filing Date:** 2/23/2004

**Examiner:** Unassigned

**Art Unit:** 1764

**PRELIMINARY AMENDMENT UNDER 37 CFR 1.115**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Continuing Application, Applicant respectfully requests that the application be amended as follows:

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 9 of this document.

**Amendments to the Drawings** begin on page 13 of this document, and include an attached replacement drawing sheet and an annotated sheet showing changes.

**Remarks/Arguments** begin on page 14 of this document.

Please amend the application as follows:

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